

<b>Notice of References Cited</b>	Application/Control No. 10/593,788		Applicant(s)/Patent Under Reexamination NAKASHIMA ET AL.	
	Examiner HUI CHIN		Art Unit 1796	Page 1 of 1

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	U	Translation of JP 2003055528, February 2003.
	V	Translation of JP 2003026896, January 2003.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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